

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)

Docket Number (Optional)

02008.152001; AT-0033US

Application Number

101786488

Applicant(s)

Seiichiro YAGI

Filing Date

HEREWITH

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	A1	6-10880	02/10/1994	Japan	G01S	7/50		✓
JL	A2	2001-229717	08/24/2001	Japan	F21S	8/12		✓
JL	A3	2002-219993	08/06/2002	Japan	B60Q	1/02		✓
JL	A4	2002-219994	08/06/2002	Japan	B60Q	1/02		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

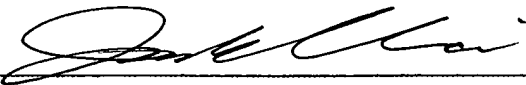
JL	A5	Patent Abstracts of Japan; Publication No. 2001-229717 dated 08/24/2001 (1 pg.)
JL	A6	Patent Abstracts of Japan; Publication No. 2002-219993 dated 08/06/2002 (1 pg.)

EXAMINER

DATE CONSIDERED

07/20/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		Docket Number (Optional) 02008.152001; AT-0033US		Application Number 107864988
		Applicant(s) Seiichiro YAGI		
		Filing Date HEREWITH		Group Art Unit
*EXAMINER INITIAL	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
JL	BI	Patent Abstracts of Japan; Publication No. 2002-219994 dated 08/06/2002 (1 pg.)		
EXAMINER	DATE CONSIDERED			
	08/20/05			
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.				